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Sulfonic SiO₂ nanocolloid doped perfluorosulfonic acid films with enhanced water uptake and inner channel for IPMC actuators

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This study provides a facile and effective strategy to fabricate sulfonic SiO₂ nanocolloid (HSO₃-SiO₂) doped perfluorosulfonic acid (PFSA) films with enhanced water uptake and inner channel for high-performance and cost-effective ionic exchange polymer metal composite (IPMC) actuators. A commercial precursor of mercaptopropyl trimethoxysilane was hydrolyzed to form thiol functionalized SiO₂ nanocolloids (SH-SiO₂, ~25 nm in diameter), which were further oxidized into sulfonic SiO₂ nanocolloids (HSO₃-SiO₂, ~14 nm in diameter). Both SiO₂ nanocolloids were used as additives to dope PFSA film for fabricating IPMC-used matrix films. Due to difference of compatibility, the SH-SiO₂ nanocolloids take phase separation in the cocrystallization course, and aggregate into huge, regular spherical particles with a mean diameter of ~690 μm; while the HSO₃-SiO₂ nanocolloids are completely compatible with PFSA, forming a very homogeneous hybrid matrix film. Related physicochemical investigations by analytical tools revealed that, the resultant HSO₃-SiO₂ hybrid film shows better IPMC-related properties compared to the SH-SiO₂ hybrid film: 1.59 folds in water uptake, and 2.37 folds in ion exchanging capacity, thus contains an increased number of cations and possesses larger and better interconnected inner channels for IPMC bending. Consequently, the HSO₃-SiO₂ hybrid IPMC actuator exhibits remarkably higher levels of actuation behaviours such as higher force output, higher displacement output, and longer stable working time, which could be used as a valuable artificial muscle for flexible actuators or displacement/vibration sensors at low cost.

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Introduction

Ion-exchange polymer metal composites (IPMCs) are flexible actuators made of smart materials that respond to deformation based on external electrical stimulation.¹⁻⁴ Due to high energy density and large displacement output under very low driving voltages (usually less than 5.0 V), they are widely used in bio-mimic robotic actuators, artificial muscle, and dynamic sensors.⁵⁻¹¹ For conventional IPMC actuators, an ion exchanging film such as perfluorosulfonic acid (PFSA, a commercial name of Nafion) or perfluorocarboxylic acid, is sandwiched between two inert metal (typically Pt) sheets as working electrodes. When an electric field is applied, force and displacement are generated due to the migration of hydrated cations in inner channels.¹² According to this actuation mechanism, IPMC's electromechanical response is closely related to

migration rate of the hydrated cations, which depends on water uptake (WU) of the matrix film. However, the pure PFSA film always exhibits a poor hydrophilicity, cannot save much water for supporting IPMC actuation longtime in air, thus limits its commercial applications. Hydrophilic silicate species such as SiO₂ particles and montmorillonite (MMT) flakes were commonly used additives to improve the WU of PFSA matrix as well as its mechanical performance, and those hybrid IPMC actuators therefore exhibited enhanced force output and elongated stable actuation time.¹³⁻¹⁷

The main chain of DuPont PFSA is a linear hydrophobic structure, which takes microphase separation and crystallizes into a non-ionic phase; conversely, the branch chains of sulfonic groups are hydrophilic, and form an ionic phase with adsorbed water molecules.^{18,19} Ionic domains aggregate to form inner channels, allowing hydrated cations to migrate. Thus the matrix film containing more sulfonic acid or carboxylic acid groups can produce larger and better interconnected inner channels for ion migration.²⁰ DuPont PFSA possesses a varying ion exchanging capacity (IEC) of 0.90-1.05 mmol g⁻¹, usually forms inner channels with varying diameters of 4-5 nm.²¹ To further enhance IEC, many sulfonic additives such as sulfonic acid functionalized polystyrene,²²⁻²⁴ graphene oxide,²⁵ carbon

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nanotubes,^{26,27} poly(ether ether ketone),²⁸ and polysulfone^{29,30} were doped to fabricate hybrid IPMC actuators with improved electromechanical behaviours.

Sulfonic acid functionalized SiO₂ might be a most promising additive considering its high WU and IEC. Former papers had reported the preparation techniques of Nafion hybrid films containing sulfonic SiO₂ additives for applications in direct methanol fuel cells.^{31–33} Li's group doped fumed silica into Nafion and then grafted sulfonic acid on the silica surface by sulfonation of concentrated H₂SO₄, the resultant composite film exhibited good ionic current and proton conductivity.³² Ren' group introduced active thiol group into the silica doped Nafion, and then converted the –SH group to the –SO₃H group by oxidation.³³ The resultant hybrid film exhibited enhanced mechanical properties, but endured shortages of low IEC and proton conductivity, when compared to the pure Nafion film.

Herein, we developed a facile and effective strategy to fabricate sulfonic SiO₂ doped PFSA (HSO₃–SiO₂/PFSA) film with enhanced WU and IEC. As shown in Fig. 1, a commercial thiol precursor of mercaptopropyl trimethoxysilane was hydrolyzed to form thiol functionalized SiO₂ nanocolloids (SH–SiO₂), which were further oxidized into sulfonic SiO₂ nanocolloids (HSO₃–SiO₂) for using as additive of PFSA. Because the sulfonic acid group is rather compatible with PFSA, no evident phase separation happened during the cocrystallization course, and a very homogeneous copolymer film of HSO₃–SiO₂/PFSA was yielded. Related physiochemical investigations by analytical tools revealed that, this new hybrid film exhibited high WU, strong IEC, and fast Li⁺ ion conductivity, without a sacrifice of mechanical strength, which can be used to fabricate high-performance and cost-effective IPMC actuators. We therefore provide a practical technique to fabricate commercialized actuators or displacement/vibration sensors at low cost.

Experimental section

Materials

Perfluorosulfonic acid solution (DuPont DE-2021, 20 wt%) with a total acid capacity of 0.95 meq. g^{–1} was purchased from DuPont Company. Poly(dimethylsiloxane) (PDMS, Sylgard 184) was obtained from Dow Corning (Midland, USA). Pt(NH₃)₄Cl₂, (3-mercaptopropyl)trimethoxysilane (KH590), H₂O₂ (30 wt%), dry ethanol and dimethyl formamide (DMF) were obtained from Sigma Aldrich.

Preparation and characterization of sulfonic silica nanocolloids

Thiol functionalized SiO₂ nanocolloids (SH–SiO₂) were prepared by hydrolysis of the precursor KH590. 2.0 mL of pure KH590 was added into a mixture containing 18.0 mL of ethanol and 2.0 mL of deionized water (pH = 2.0), this mixture was permitted to react for 90 min at 80 °C under violently stirring. After complete hydrolysis of the KH590, the product was dialysed in anhydrous ethanol three times to remove excess water (weight cutoff of the dialysis bag was 300). Finally, the solution was concentrated to 2.0 mL by a rotating evaporator, thus

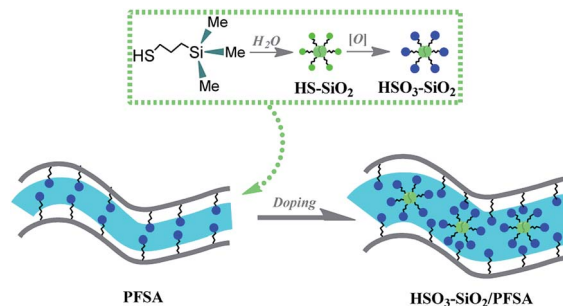


Fig. 1 Formation of HSO₃–SiO₂ doped PFSA film. Thiol precursor of KH590 is hydrolyzed and oxidized to form the HSO₃–SiO₂ nanocolloids, which are doped into PFSA to form a hybrid matrix film after cocrystallization. Due to introduction of substantial sulfonic acid groups, the hybrid film exhibits higher hydrophilicity, larger and better interconnected inner channels, which benefit to improve IPMC's electromechanical performance.

obtaining a colorless and transparent colloid solution containing around 1.08 g SH–SiO₂ nanocolloids.

Prior to concentrating, 20.0 mL of hydrogen peroxide (30%) was added into the above mixture for oxidizing the –SH. The oxidation reaction was performed under 60 °C for 24 h, then the resultant mixture was concentrated to 2.0 mL. A colorless and transparent colloid solution containing around 1.59 g HSO₃–SiO₂ nanocolloids was yielded.

Both the SH–SiO₂ and HSO₃–SiO₂ nanocolloids were observed by transmission electron microscopy (TEM, JEM-2100) for morphology characterization. To obtain their chemical component information, they were dropped onto a glass slide, drying for X-ray photoelectron spectroscopy (XPS, ESCA Multi-lab 2000) and (ATR-FTIR, Bruker IFS66/S) analyses.

Preparation and characterization of PFSA hybrid films

The PFSA hybrid films were prepared by cocrystallization of PFSA with the functionalized SiO₂ nanocolloids. 1.0 mL concentrated SH–SiO₂ or HSO₃–SiO₂ colloid solution was added into two mixtures containing 18.0 mL of PFSA (20 wt%) and small amount of DMF. The mixtures were vigorously stirred for uniformly mixing, and respectively poured into two self-made PDMS-based containers (75 × 80 × 50 mm³), followed by crystallizing *via* solvent removal at 60 °C for 48 h. A SH–SiO₂/PFSA

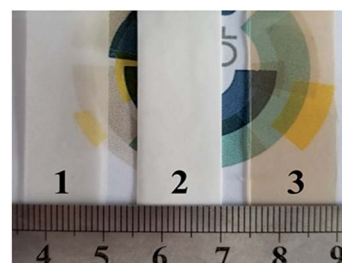


Fig. 2 Optical images of (1) pure PFSA (control), (2) SH–SiO₂/PFSA, and (3) HSO₃–SiO₂/PFSA films.



Table 1 Atomic concentrations of the additives and matrix films

| Sample | Atomic concentration (atom%) | | | | | |
|--|------------------------------|-------|------|-------|-------|-------|
| | C | O | Si | F | S(II) | S(VI) |
| SH-SiO ₂ | 65.73 | 24.75 | 6.86 | 0 | 2.66 | 0 |
| HSO ₃ -SiO ₂ | 65.46 | 25.98 | 6.67 | 0 | 0 | 1.89 |
| Pure PFSA | 35.33 | 8.11 | 0.18 | 54.29 | 0 | 2.09 |
| SH-SiO ₂ /PFSA | 32.91 | 9.64 | 1.52 | 53.19 | 0.36 | 2.38 |
| HSO ₃ -SiO ₂ /PFSA | 31.87 | 10.53 | 2.22 | 52.31 | 0 | 3.07 |

hybrid film (white color, ~ 0.46 mm thickness) and a HSO₃-SiO₂/PFSA hybrid film (light yellow color, ~ 0.38 mm thickness) were obtained (Fig. 2). For comparison, 18.0 mL of PFSA solution was poured into the above container to make a pure PFSA film (control, white color, ~ 0.31 mm thickness). To study the relationship between film thickness and electromechanical property, two other HSO₃-SiO₂/PFSA hybrid films with different thicknesses of 0.34 and 0.41 mm were prepared by using 0.50 and 1.50 mL HSO₃-SiO₂ solution. All PFSA films were annealed at 150 °C for 5 min before use.

Surface chemical component and electronic structure of PFSA family films were detected by high resolution XPS. Young's modulus, IEC, WU, and water contact angle (CA) of the matrix films were determined refer to our former reports.^{34,35} The PVDF films were grounded into pieces for thermogravimetric analyses (TG, SDTQ600). All samples were heated from the room temperature to 800 °C at a heating rate of 10 °C min⁻¹ under N₂.

Morphology characterizations and performance measurements of IPMCs

Refer to former literatures, the PFSA matrix films were deposited Pt nano electrodes for fabricating IPMCs.^{17,36} To generate a stronger electrochemical response, IPMCs were incubated in a LiOH (0.05 mol L⁻¹) solution before usage. Surface morphologies of IPMCs were detected by a field emission scanning electron microscope (FESEM) (S4800, Hitachi, Japan) using a Schottky field emission source. The IPMC samples were placed into the liquid nitrogen for 30 min, and then broken. Before SEM observation, samples were deposited by gold particles (~ 5 nm) for conductivity.

The electromechanical behaviours of the three IPMC actuators were determined by our custom system, which consists of a signal generator, a signal amplifier, a force sensor, and a laser displacement sensor. The signal generator has a multifunction data acquisition card (NI, 6024E), which can produce electrical signals with frequencies in the range of 0.1–100 Hz, voltages in the range of 0–10 V, and different waveforms (square, sinusoid and triangle). A force sensor with a sensitivity of 0.1 mN (CETRU-MT) and a laser displacement sensor with a sensitivity of 0.1 μ m (LK-G80) were used to acquire force and displacement data. The IPMC end was aligned with the tip of the force sensor in an equilibrium position and collected the blocking force from one side. All IPMC samples were cut in same size of (30 \times 5 mm²) to detect and compare their electromechanical properties.

Results and discussion

Morphology and component characterizations of functionalized SiO₂ nanocolloids

Fig. 3a and b present similar, amorphous capsule structures of the SH-SiO₂ and HSO₃-SiO₂ nanocolloids. Because the latter possesses a higher dispersibility in the polar environment (mixture of ethanol and water) as compared to the former, its mean dimension (~ 14 nm) is lower than that of the former (~ 25 nm), showing much finer nanocolloids. IR and XPS analyses confirm the chemical component of both nanocolloids, and are shown in Fig. 3c and d. For the IR of SH-SiO₂, appearances of a broad Si-OH stretching at 3432 cm⁻¹ and a double Si-O-Si stretching at 1113 and 1065 cm⁻¹ suggest that the KH590 was hydrolyzed by water. After oxidation by H₂O₂, a complete disappearance of S-H stretching band at 2550 cm⁻¹ and appearances of three new bands (S=O asym stretching at 1156 cm⁻¹, S=O sym stretching at 1032 cm⁻¹, and O=S=O asym stretching at 1352 cm⁻¹) demonstrate the successful oxidation of the thiol group.³⁷ Additionally, sharp peaks in the range 2800–3000 cm⁻¹ are resulted from the propyl chain of the organic linker; a stronger, broader O-H band appears at the curve of HSO₃-SiO₂, showing that the sulfonic acid group has a stronger affinity to water compared to its precursor.

The successful oxidation of thiol group is further confirmed by XPS detection. Fig. 3d and Table 1 recorded the high resolution S 2p XPS data of both SiO₂ nanocolloids. For the SH-SiO₂ nanocolloids, the S 2p spectra consists of two components at 163.1 and 164.4 eV, resulting from the sulfur with a valence of -2, the former peak is derived from the S-H bond, while the latter peak is derived from the C-S bond.^{38,39} For the HSO₃-SiO₂ nanocolloids, a broad peak belongs to the sulfur with a valence of +6, resulting from sulfonic acid group. Collectively, the above results confirm the successful preparation of the sulfonic SiO₂ nanocolloids.

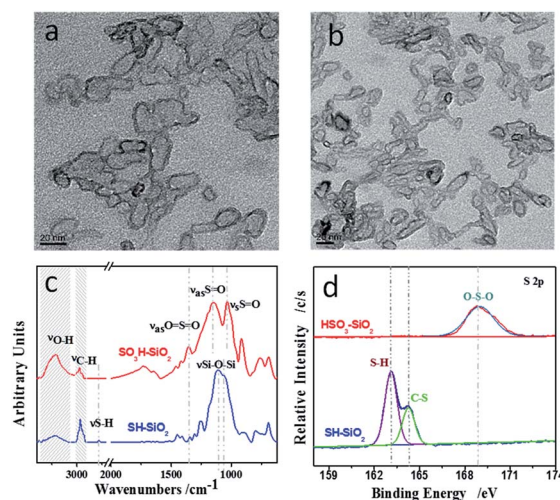


Fig. 3 TEM images of (a) SH-SiO₂ nanocolloids, and (b) HSO₃-SiO₂ nanocolloids; comparisons of (c) ATR-FTIR spectra and (d) high resolution S 2p XPS spectra.



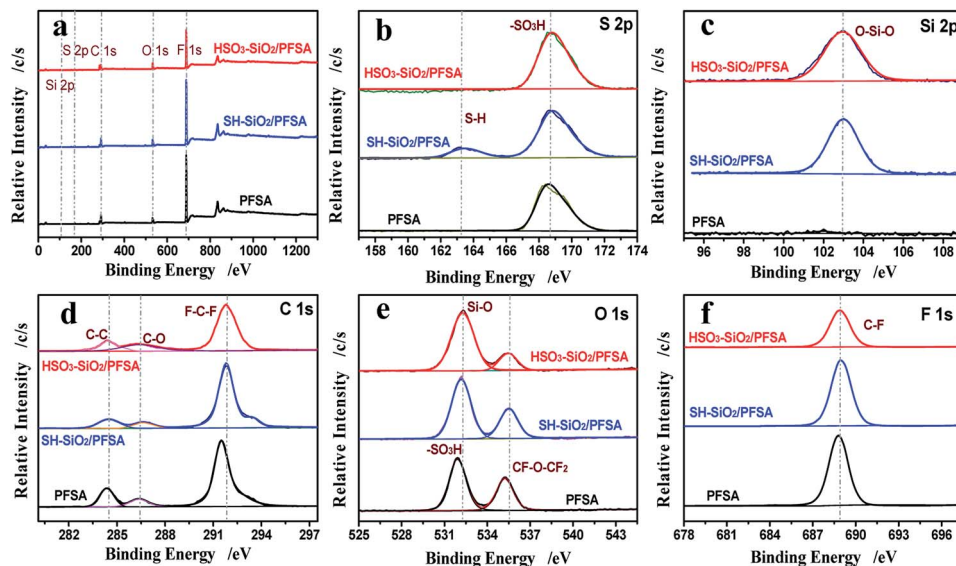


Fig. 4 XPS analyses. Survey scans of the PFSA, SH-SiO₂/PFSA, HSO₃-SiO₂/PFSA films (a); high resolution XPS spectra of S (b), Si (c), C (d), O (e), and F (f) elements.

XPS characterizations of PFSA hybrid films

Fig. 4 and Table 1 compare the XPS data from the PFSA family films. Peaks of C 1s, S 2p, O 1s, F 1s, and Si 2p are shown in their survey scan curves (Fig. 4a). For the high resolution S 2p spectrum (Fig. 4b), a peak of sulfonic acid group appears at 168.6 eV, resulting from the exposed PFSA; after doping the SH-SiO₂ nanocolloids, a new peak of S-H group appears at 163.2 eV; after doping the HSO₃-SiO₂ nanocolloids, only an enhanced peak of sulfonic acid group remains with enhanced S element concentration increasing from 2.74% to 3.07% (Table 1), this increase is resulted from the doping of sulfonic additives. For the high resolution Si 2p spectrum (Fig. 4c), no Si signal is seen for the control, while a strong Si-O-Si signal appears at 103.0 eV in both hybrid film curves, generating from the additives of SiO₂ nanocolloids.⁴⁰ Si element concentration varies from 1.52% of the SH-SiO₂/PFSA film to 2.22% of the HSO₃-SiO₂/PFSA film, the change was derived from the different aggregation states of Si. Additional information such as decreases of C and F elemental concentrations and increase of O elemental concentration further confirm the doping of functionalized SiO₂ nanocolloids (Fig. 4d–f, Table 1).

IPMC-related property characterizations

Introduction of functionalized SiO₂ nanocolloids significantly changes the matrix film's polarity, WU, IEC, and mechanical property, thus affecting IPMC's electromechanical performance.^{31–35,41} The detected water CAs are 84.1, 75.7, and 54.5° for the pure PFSA, SH-SiO₂/PFSA, and HSO₃-SiO₂/PFSA films, respectively (Fig. 5a and Table 2), thus both hybrid films become more hydrophilic due to additions of SiO₂ nanocolloids, whose surfaces widely distribute hydrophilic Si-OH and Si-O-Si groups. The HSO₃-SiO₂/PFSA film exhibits the best hydrophilicity among those films due to the strong polarity of sulfonic acid function.

Data of WUs exhibit similar changing trend to CAs: WU of the HSO₃-SiO₂/PFSA film is higher than that of the SH-SiO₂/PFSA film, which is higher than that of the control (Table 2). The detected WU of the HSO₃-SiO₂/PFSA film is 32.2%, increasing by 1.80 folds when compared to the control. Notably, water-driven IPMC actuators always experience water shortage due to significant evaporation and electrolysis when the hydrated cations move fast between two electrodes.^{34,35} Thus, high WU is important to ensure their actuation stability.

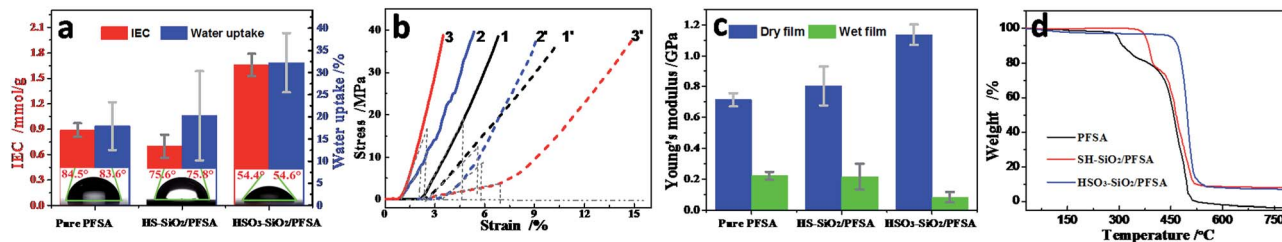


Fig. 5 IPMC-related parameters. (a) Comparisons of IEC and WU for PFSA family films (the inserted images are their captured CA images); (b) typical stress–strain curves, solidline 1, 2, 3 and dashed line 1', 2', 3' are from the control, SH-SiO₂/PFSA, and HSO₃-SiO₂/PFSA films in the dry or wet state, respectively; (c) comparisons of Young's moduli; (d) TG curves.



Table 2 IPMC-related parameters for the control, SH-SiO₂/PFSA, and HSO₃-SiO₂/PFSA films

| Samples | Thickness/mm | PFSA concentration/% | CA/° | WU/% | IEC/mmol g ⁻¹ | Young's moduli/MPa | | <i>T</i> _{dec} of backbone/°C |
|--|--------------|----------------------|------|------|--------------------------|--------------------|-----|--|
| | | | | | | Dry | Wet | |
| Pure PFSA | 0.31 | 100 | 84.1 | 17.9 | 0.89 | 714 | 221 | 438 |
| SH-SiO ₂ /PFSA | 0.46 | 87.0 | 75.7 | 20.3 | 0.70 | 804 | 216 | 446 |
| HSO ₃ -SiO ₂ /PFSA | 0.38 | 81.8 | 54.5 | 32.2 | 1.66 | 1135 | 83 | 464 |

Because the sulfonic acid group possesses a strong ionization ability, the pure HSO₃-SiO₂ has a remarkably theoretic IEC of 6.76 mmol g⁻¹, given the SH group is completely converted to the SO₃H group. In our experiment, the HSO₃-SiO₂/PFSA film exhibits a detected IEC of 1.66 mmol g⁻¹, which is around 1.90 folds of the self-casting pure PFSA, or 1.86 folds of the commercial Nafion film.^{42,43} But for the SH-SiO₂/PFSA film, because Si-OH and Si-SH hardly provide ion exchanging ability, its detected IEC is only 0.70 mmol g⁻¹, which is even lower than the control of 0.89 mmol g⁻¹. It should be noted that, the enhanced IEC would provide more inner channels, which benefits numerous ions migrating at the same time, thus might produce strong force and power outputs.⁴⁴

To evaluate the compatibility between SiO₂ additives and PFSA matrix films, mechanical properties of the resultant hybrid films were detected by a nanoindenter. Fig. 5b and c show the typical stress-strain curves and the calculated Young's moduli, while their detailed parameters are shown in Table 2. Clearly, all PVDF films exhibit a linear elastic region followed by a nonlinear deformation. In the dry state, the self-casting, pure control film shows a compressive Young's modulus of 714 MPa, which is higher than the commercial Nafion film of around 220 MPa in same membrane thickness.⁴⁵ After doping functionalized SiO₂ nanocolloids, the mechanical properties get

apparently improved, the detected Young's moduli are 804 MPa for the SH-SiO₂/PFSA film and 1135 MPa for the HSO₃-SiO₂/PFSA film, respectively increasing to 1.13 and 1.59 folds compared to the control. Thus the HSO₃-SiO₂/PFSA film shows the strongest mechanical strength among these films, indicating a good compatibility between the HSO₃-SiO₂ nanocolloids and the PFSA. After absorbed water, all three matrix films exhibit attenuated mechanical properties. Due to high hydrophilicity and WU, the HSO₃-SiO₂/PFSA film exhibits the lowest yield modulus of 83 MPa in the wet state, only 7.3% remains compared to the value in the dry state, suggesting a high flexibility, therefore the HSO₃-SiO₂/PFSA IPMC is expected to generate larger deformation.

Fig. 4 compares the thermal properties of the three matrix films. For the control, three stages of weight losses, respectively beginning at 285, 399, and 438 °C, correspond to the thermal decomposition temperatures (*T*_{dec}) of sulfonic group, branch chain, and C-F backbone. After embedded the SH-SiO₂ particles, those *T*_{dec} data get evidently increased, shifting to 355, 405, and 446 °C, respectively. But for HSO₃-SiO₂/PFSA, only one strong weight loss at 464 °C is found, showing a high thermal stability of the HSO₃-SiO₂/PFSA film. Increases of *T*_{dec} hint a presence of strong interactions between the HSO₃-SiO₂ nanocolloids and the PFSA, further demonstrates a high compatibility between them.

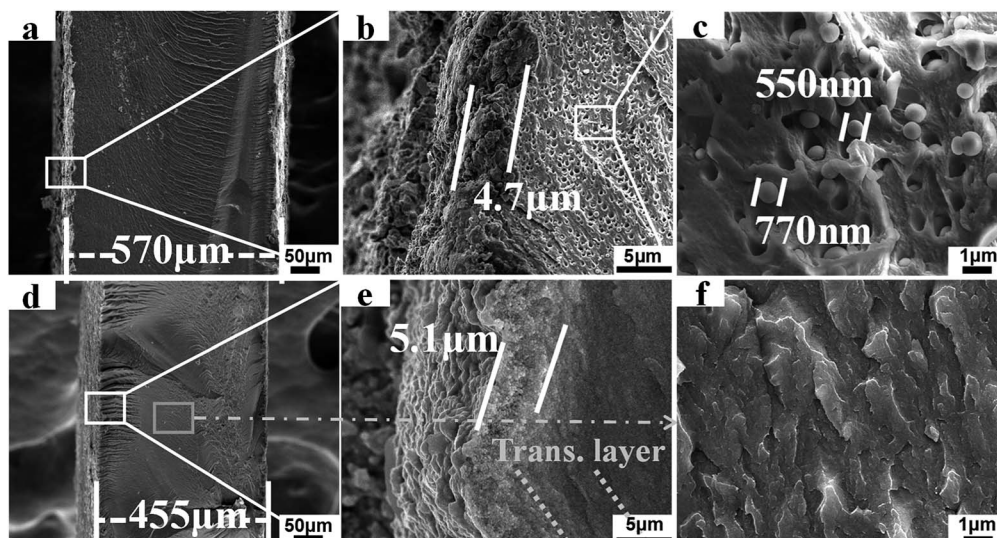


Fig. 6 SEM image. Cross section profiles, interface connections, matrix morphologies of the SH-SiO₂/PFSA (a-c) and HSO₃-SiO₂/PFSA (d-f) based IPMCs.



IPMC morphology characterizations

Fig. 6 records and compares SEM morphologies of the two hybrid film IPMCs. As shown in Fig. 6a and d, the total thicknesses including Pt nanosheets and the matrix film are 570 μm for the SH-SiO₂/PFSA based IPMC and 455 μm for the HSO₃-SiO₂/PFSA based IPMC. Because the latter matrix film has a higher IEC, more Pt precursor ions of [Pt(NH₃)₄]²⁺, which act as counter cations to balance the sulfuric acid anions, were absorbed and reduced into the Pt nanograins. As a result, the HSO₃-SiO₂/PFSA based IPMC presents a thicker Pt electrode. Notably, increasing the electrode thickness of IPMC benefits to overcome the electrode defects, and improve the electronic conductivity and “granular damming effect”.^{46,47} What is important, an evident transition layer generates from the interface between Pt electrode and the polymer matrix in HSO₃-SiO₂/PFSA based IPMC (Fig. 6e), while nearly nothing is found in SH-SiO₂/PFSA based IPMC (Fig. 6b). This result hints that, a more stable connection was yielded between the Pt nanosheets and the HSO₃-SiO₂/PFSA matrix, which would prevent the separation of Pt nanograins from the matrix surface and ensure a stable electromechanical response.⁴⁸

A striking difference generates from the Fig. 6c and f the SH-SiO₂/PFSA, many isolated spherical particles and closed pores with a mean dimension of around 690 μm are observed (Fig. 6c). Those huge spherical particles should be the SH-SiO₂ particles, which were generated from the microphase separation during cocrystallization course. Because the SH-SiO₂ nanocolloids are not compatible with the PFSA, they would aggregate together forming the huge spherical particles.³⁵ Induced by the exterior polar, protonic environment, the hydrophilic Si-OH group should be exposed outside and produces H-bond interaction with the sulfonic acid group from PFSA, while the lower hydrophilic group of thiol should be buried inside. Supposed this hybrid film is oxidized by H₂O₂ *in situ*, only the naked, small amount thiol groups get opportunity of oxidation and turn into sulfonic acid groups, most of thiol groups can not be oxidized. Clearly, this strategy can not produce high IEC film.

Those closed pores generated from the removal of the SH-SiO₂ particles, which might happen during the nitrogen cooling fracture process. The presence of pores also demonstrates the poor compatibility between the SH-SiO₂ nanocolloids and the PFSA. That is why an opaque white color film of SH-SiO₂/PFSA is seen in Fig. 2. However, due to introduction of sulfonic functions, the HSO₃-SiO₂ nanocolloids exhibit a high chemical compatibility with the PFSA, thus a very homogeneous copolymer of HSO₃-SiO₂/PFSA is yielded, no evident particles or pores is seen in Fig. 6f, and a transparent film is observed in its optical image (Fig. 2).

Investigation of possible electromechanical response of IPMCs

Actuations of IPMCs were captured and shown in Fig. 7. Clearly, all IPMCs from the pure PFSA, SH-SiO₂/PFSA, and HSO₃-SiO₂/PFSA films generate stable electromechanical bending, and their maximum swing angles are 65, 28, and 110°, respectively. According to the electromechanical response mechanism,

driven by the electric field, hydrated Li⁺ ions migrate from the anode to the cathode, thus forms a water concentration gradient, causing IPMC to bend towards the anode.^{1,49,50} Therefore, the amounts of hydrated Li⁺ ions and inner channels are critical to IPMC bending.^{17,49} Due to introduction of the hydrophilic sulfonic acid groups, the HSO₃-SiO₂/PFSA film possesses a higher IEC and a higher WU when compared to the control, those data potentially increase to 1.87 and 1.80 folds, respectively (Table 2). Thus the doping of HSO₃-SiO₂ nanocolloids benefits to improve IPMC actuation as discussed below. (1) because the polar sulfonic acid group takes part in the formation of inner channel, thus the hybrid film would possess enlarged and more interconnected inner channels.⁴⁶ (2) Substantial Li⁺ ions are introduced into the hybrid film as counter cations to balance the sulfonic acid anions, thus provides enough movable hydrated cations to migrate. (3) Driven by the electric field, the hydrated cations (*i.e.*, Li⁺) migrate from one end of sulfonic acid group to another end along inner channels, therefore a large number of sulfonic acid groups provide a large number of ion exchanging sites, supporting the fast migration of hydrated cations.⁵¹ Additionally, high WU of the matrix film also brings two evident benefits for IPMC as discussed below. (1) High WU makes the matrix film flexible, which benefits to generate larger deformation; (2) high WU benefits to maintain stable concentration of the hydrated cations, and subsequently stable actuation, because IPMC cannot work without electrolyte solution.⁵² Overall, increasing IEC and improving the hydrophilicity of the matrix film are effective strategies to enhance IPMC electromechanical deformation.

Electromechanical performance analyses of IPMCs

Displacement and force outputs are two important parameters for assessing IPMC electromechanical response.⁵³ Typical displacement and force output curves are recorded in Fig. 8a and d. By using a sinusoid signal as the driving source, both

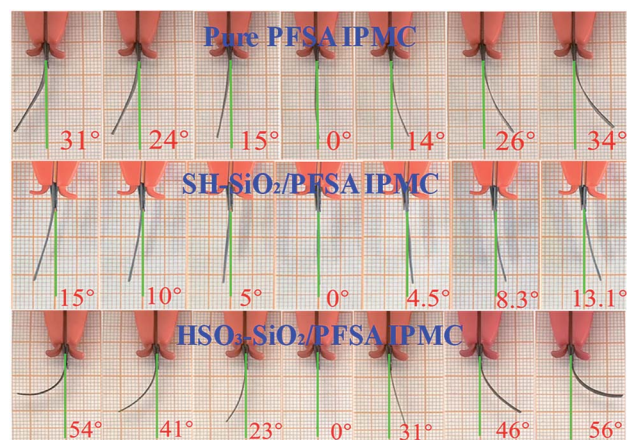


Fig. 7 Actuation images of the pure PFSA IPMC (control, top), SH-SiO₂/PFSA IPMC (middle), and HSO₃-SiO₂/PFSA IPMC (bottom) actuated by a sinusoidal wave with a frequency of 0.1 Hz under an AC voltage of 2.5 V.



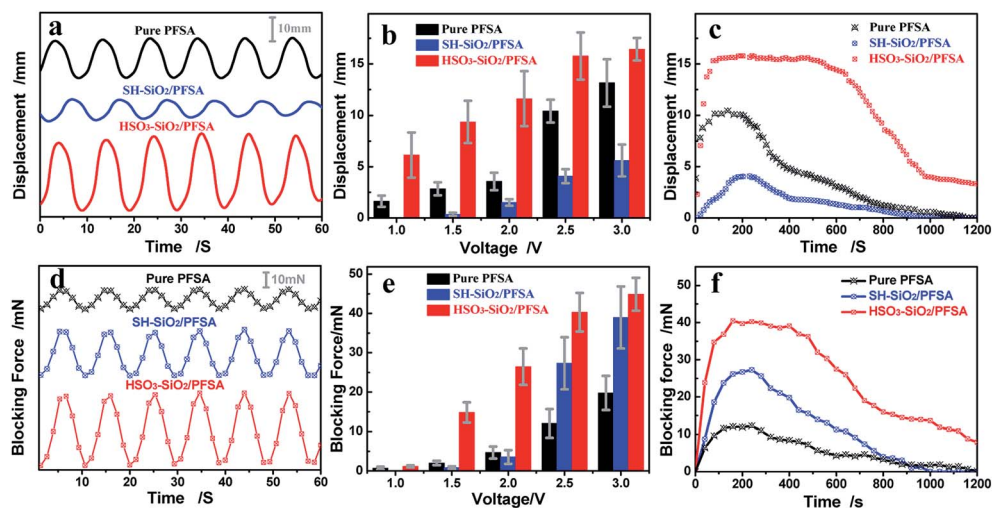


Fig. 8 Comparisons of IPMC electromechanical properties. Typical displacement curves (a) and blocking force curves (d) under 2.5 V driving voltage; columns of displacement (b) and force (e) vs. driving voltage; evolution curves of displacement (c) and force (f) vs. time under 2.5 V driving voltage. For comparison, AC signals adopted a sinusoid wave of 0.1 Hz. The mean actuation displacement was calculated from half of the difference of peak displacement and bottom displacement in one circle. The blocking force was collected at the balanced site, equalled the difference of peak force and bottom force in one circle.

displacement and force curves exhibit typical sinusoid characterization, showing a good correlation between the electromechanical behaviour and the driving electric field. Fig. 8b and e record the displacement and force evolution curves with increasing the driving voltage. Voltages of 1.0–3.0 V were used to drive IPMC actuators. Clearly, both displacement and force increase with increasing the driven voltage. Under the same actuation voltage of 2.5 V, three IPMC actuators from the control, SH-SiO₂/PFSA, and HSO₃-SiO₂/PFSA matrix films exhibit maximum displacement outputs of 10.43, 4.08, 15.77 mm, and maximum force outputs of 12.03, 27.32, 40.03 mN, respectively (Table 3). Their total deflection angles including left and right swing angles are 65, 28, and 110°, respectively (Table 3). Collectively, IPMC of HSO₃-SiO₂/PFSA exhibits the strongest displacement and force outputs, resulting from the high IEC, WU, Li⁺ ion conductivity, and flexibility of the matrix film.

Profiles of displacement and force outputs shown in Fig. 8c and f confirm the above results. Under the same actuation voltage of 2.5 V, all three displacement curves exhibit an initial rise followed by a relatively stable displacement output, corresponding to the stable working time for the actuator. This result might be explained by the fact that, all the inner channels are

not completely interconnected and the hydrate Li ions migrate and gradually open the inner channels driven by electric field.^{34,35} Finally, the electromechanical response goes recession with the water loss (Fig. 8c). As the blocking force of IPMC originates from its deformation, force profiles shown in Fig. 8f correlate well with displacement profiles shown in Fig. 8c. Based on HSO₃-SiO₂/PFSA film with varying thicknesses of 0.34–0.41 mm, the detected forces of IPMCs increase from 26.31 mN to 44.45 mN, but the deflection angles decrease from 118° to 89° under 2.5 V driven voltage, showing a competitive correlation between force output and displacement output, where a thicker matrix film always leads to smaller deformation and larger blocking force.

Additional evidence shows improved working time performance of HSO₃-SiO₂/PFSA compared to control. With continuous actuation in air, IPMC actuators may lose almost all water and subsequently stop actuation.⁵² Under the driving voltage of 2.5 V, the HSO₃-SiO₂/PFSA based IPMC exhibits a stable bending time of more than 580 s, its force output also keeps stable for 440 s, both data are much better than other two IPMCs (Table 3). Collectively, the HSO₃-SiO₂ hybrid IPMC actuator exhibits better electromechanical properties compared

Table 3 Comparisons of the electromechanical outputs of IPMC actuators

| Sample | Max displacement at 2.5 V mm ⁻¹ | Stable working time at 2.5 V s ⁻¹ | Total deflection angle at 2.5 V ° ⁻¹ | Max blocking force at 2.5 V mN ⁻¹ | Max displacement at 3.0 V mm ⁻¹ | Stable working time at 3.0 V s ⁻¹ | Total deflection angle at 3.0 V ° ⁻¹ | Max blocking force at 3.0 V mN ⁻¹ |
|--|--|--|---|--|--|--|---|--|
| Pure PFSA | 10.43 | ~130 | 65 | 12.03 | 13.16 | ~110 | 86 | 19.74 |
| SH-SiO ₂ /PFSA | 4.08 | ~230 | 28 | 27.32 | 5.61 | ~150 | 39 | 38.97 |
| HSO ₃ -SiO ₂ /PFSA | 15.77 | >580 | 110 | 40.03 | 16.43 | >240 | 112 | 44.87 |



to the pure PFSA film IPMC actuator: 1.51 folds in displacement output, 3.33 folds in force output, and 4.46 folds stable working time. Based on above results, we conclude that: introduction of sulfonic SiO₂ nanocolloids can significantly enlarge the inner channels, increase the density of inner channels, and increase ion exchange rate, thus enhancing the IPMC's electromechanical properties.

Conclusions

Sulfonic SiO₂ nanocolloids (HSO₃-SiO₂) were fabricated by initial hydrolysis of the commercial precursor of (3-mercaptopropyl)trimethoxysilane, thus forming thiol functionalized SiO₂ nanocolloids (SH-SiO₂), followed by oxidization of thiol group into sulfonic acid group. IR and high resolution XPS spectra monitored the total reaction courses, and demonstrated the successful preparation of the title nanocolloids. High resolution TEM observations revealed that, both SiO₂ nanocolloids presented similar, amorphous capsule structure, their mean diameters were ~14 nm for the HSO₃-SiO₂ nanocolloid, and ~25 nm for the SH-SiO₂ nanocolloid. Both SiO₂ nanocolloids were used as additives to modify the PFSA film for fabricating IPMC-used matrix films. FESEM observations of hybrid films revealed that, the SH-SiO₂ nanocolloids took evident phase separation in the cocrystallization course, and aggregated into huge, regular spherical particles with a mean diameter of ~690 nm, which separately dispersed in the matrix film; while the HSO₃-SiO₂ nanocolloids were rather compatible with the PFSA, thus forming a very homogeneous copolymer. Other related physiochemical investigations by analytical tools revealed that, the HSO₃-SiO₂ hybrid IPMC actuator exhibits better electromechanical properties compared to the pure PFSA film IPMC actuator: 1.51 folds in displacement output, 3.33 folds in force output, and 4.46 folds stable working time. Such high-performance and cost-effective IPMC could be used as a valuable artificial muscle for flexible actuators or displacement/vibration sensors at low cost.

Conflicts of interest

There are no conflicts to declare.

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